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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2823

Application No.: 10/684,874

Examiner: M. Estrada

Filed: October 15, 2001

Docket No.: 109725.01

For: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER

CORRECTION OF SEPTEMBER 29, 2004 INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Information Disclosure Statement submitted September 29, 2004 erroneously did not attach a copy of the U.S. patent references listed on the Form PTO-1449. Accordingly, attached are copies of the references. The Examiner is requested to initial the Form PTO-1449 submitted with the September 29, 2004 Information Disclosure Statement.

Any questions arising with regard to this communication should be directed to Applicant's representative at the telephone number set forth below.

Respectfully submitted,

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Date: October 15, 2004

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